



Image

Patent
Attorney Docket No. 018765-177

In re Patent Application of

Yoshihisa SAIMOTO et al.

Application No.: 10/506,806

Filing Date: September 7, 2004

Group Art Unit: 2811

Examiner: THOMAS J MAGEE

Confirmation No.: 5415

Title: PRESSURE SENSITIVE ADHESIVE FILM FOR PROTECTION OF SEMICONDUCTOR WAFER SURFACE AND METHOD OF PROTECTING SEMICONDUCTOR WAFER WITH THE PRESSURE SENSITIVE ADHESIVE FILM

**THIRD
INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a THIRD Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☒ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

By Robert G. Mukai
Robert G. Mukai
Registration No. 28,531

Date: July 20, 2005



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Yoshihisa SAIMOTO et al.) Group Art Unit: 2811
Application No.: 10/506,806) Examiner: THOMAS J MAGEE
Filed: September 7, 2004) Confirmation No.: 5415
For: PRESSURE SENSITIVE ADHESIVE FILM)
FOR PROTECTION OF SEMICONDUCTOR)
WAFER SURFACE AND METHOD OF)
PROTECTING SEMICONDUCTOR WAFER)
WITH THE PRESSURE SENSITIVE)
ADHESIVE FILM)

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, applicants hereby submit certain documents cited in an Office Action dated May 30, 2005 in the corresponding Singapore application in conformance with the provisions of 37 C.F.R. §§ 1.97 and 1.98.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

CERTIFICATION UNDER 37 C.F.R. §1.97(e)

I, the undersigned, hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date July 20, 2005

By: Robert G. Mukai
Robert G. Mukai
Registration No. 28,531

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

Complete if Known

JUL 20 2005

Application Number	10/506,806
Filing Date	September 7, 2006
First Named Inventor	Yoshihisa Saimoto et al.
Examiner Name	THOMAS J MAGEE
Attorney Docket Number	018765-177

Sheet	1	of	1
-------	---	----	---

[illegible][illegible]

NON-PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

*Copy attached.

Examiner
Signature

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.